

10/512131

DT01 Rec'd PCT/PTO 21 OCT 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Okuyama et al.  
Intnl. Appl. No.: PCT/JP04/001952  
Intnl. Filing Date: February 19, 2004  
Title: SEMICONDUCTOR LIGHT EMITTING ELEMENT,  
MANUFACTURING METHOD THEREOF, INTEGRATED  
SEMICONDUCTOR LIGHT EMITTING DEVICE,  
MANUFACTURING METHOD THEREOF, IMAGE DISPLAY  
DEVICE, MANUFACTURING METHOD THEREOF,  
ILLUMINATING DEVICE AND MANUFACTURING METHOD  
THEREOF  
Docket No.: 112857-534

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 37 C.F.R. 1.97, and 37 C.F.R. 1.98, Applicants request that a citation and examination of the references cited below, and on the attached PTO-1449 form, copies of which are enclosed, be made during the course of examination of the above-identified application for United States patent.

**FOREIGN PATENT DOCUMENTS**

<u>Document No.</u>	<u>Date</u>	<u>Country</u>
06-045648	02-18-1994	Japan
09-129974	05-16-1997	Japan
11-026883	01-29-1999	Japan
2002-100805	04-05-2002	Japan
2002-261327	09-13-2002	Japan

**OTHER DOCUMENTS**

Tachibana, K. et al., "Selective growth of InGaN quantum dot structures and their microphotoluminescence at room temperature," Applied Physics Letters, 29 May, 2000, Vol. 76, No. 22, pp. 3212-3214.

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Applicants look forward to early and favorable consideration of this matter.

Respectfully submitted,

BELL, BOYD & LLOYD LLC

BY 

Thomas C. Basso

Reg. No. 46,541

P.O. Box 1135

Chicago, Illinois 60690-1135

Phone: (312) 807-4310

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<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b> (Use several sheets if necessary)		Atty Docket No. 112857-534	Application No. 10/512131
PTO Form 1449		Applicant Okuyama et al.	
		Filing Date October 21, 2004	Group Unknown

<b>U.S. PATENT DOCUMENTS</b>							
Examiner's Initials		Document Number	Publication Date	Inventor	Class	Subclass	Filing Date If Appropriate

<b>FOREIGN PATENT DOCUMENTS</b>							
Examiner's Initials		Document Number	Publication Date	Country	Class	Subclass	Translation
							Yes No
		06-045648	02-18-1994	Japan			
		09-129974	05-16-1997	Japan			
		11-026883	01-29-1999	Japan			
		2002-100805	04-05-2002	Japan			
		2002-261327	09-13-2002	Japan			

Examiner's Initials	OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)
	Tachibana, K. et al., "Selective growth of InGaN quantum dot structures and their microphotoluminescence at room temperature," Applied Physics Letters, 29 May, 2000, Vol. 76, No. 22, pp. 3212-3214.

Examiner:	Date Considered:
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	